Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/600,151	HAAPALAHTI ET AL.	
Examiner	Art Unit	
Paul D. Kim	3729	

SEARCHED					
Class	Subclass	Date	Examiner		
29	594 731 753 754 761 443	10/28/2005	PK		
72	370.11	V			
		***			
			<u>.</u>		
			_		
			_		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
			-	
	ļ			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Text Search EAST/NPL (IEEE)	10/28/2005	PK	